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FJW  
OFGS File No: P/1250-293

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

YOSHIDA, Takushi et al

New York, New York

Date: January 10, 2007

Serial No.: 10/541,507

Group Art Unit: 1763

Date Filed: July 8, 2005

For: SUBSTRATE PROCESSING SYSTEM, SUBSTRATE PROCESSING  
APPARATUS, PROGRAM AND RECORDING MEDIUM

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**STATUS INQUIRY LETTER**

Sir:

We filed the above application with the U. S. Patent and Trademark Office on July 8, 2005.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

  
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Attorney: Max Moskowitz  
OSTROLENK, FABER, GERB & SOFFEN  
1180 Avenue of the Americas  
New York, New York 10036-8403  
(212) 382-0700